#### Ion/Specimen Interactions

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# How to obtain an image using SEM?

Through ion/specimen interaction
 In brief, we shoot high-energy electrons on

specimen, and analyze the outcoming electrons/X-ray

#### **SEM Setup**

 When incident beam strikes on sample, electrons are scattered elastically or inelastically; this gives various signals





- Primary Signals:
  - Secondary electrons (topographical)
  - Backscattered electrons (atomic number and topographical)
    - X-Ray (thickness composition info)

#### Interaction Volume



Actual image of beam penetration into PMMA showing size and dimension of region of primary excitation

### Secondary Electrons (SE)

- Inelastic collision between the incoming electrons and the loosely bounded outer electrons from the atom
- Low energy (10-50eV)
- Generated close to surface (topographic information)
- Number of SE is greater than the incoming electrons



#### **Backscattered Elections (BSE)**

#### Elastic collisions with the atom of the specimen

- A fraction of incident electrons is retarded by the electromagnetic field of the nucleus
- Higher energy electrons
- Generated from deeper region of the specimen
- Fewer BSE than SE
- Give atomic number information



### BSE vs. SE Image







Gold particles on E.Coli appears bright due to the higher percentage of BSE compared to the low atomic weight specimen

#### X-Ray

#### Photons

- High energy, escape from very deep region in specimen
- Most common spectrometer: EDS (energydispersive spectrometer)
- Each element has a fingerprint X-Ray signal
- Poorer spatial resolution
- Fewer X-ray signals are emitted (long colleting time required)



Top: SEM X-Ray map of Fe distribution in the Strombolian samples Bottom: Backscattering map

#### Resolution



 Resolution in SEM is determined by the region where the signal is produced

 For the same region of excitation, the resolution of the three signals decreases from SE to BSE to X-Ray

# Factors affecting size of the interaction region

- Diameter of the primary beam
- Energy of the primary beam (accelerated voltage)
- Atomic weight of the specimen
- Coating of specimen

### Accelerated Voltage



3.0 keV

20.0 keV

Accelerated voltage give more signal and brighter image

# Effects of acceleration voltage and atomic weight



 Interaction volume increases with increasing acceleration voltage

 Interaction volume decreases with increasing atomic number

#### Images: Smith College Northampton, Massachusetts



Small excitation region, no overlapping of produced signals
Resolved image

- penetration depth
- -Larger excitation region, overlapping of produced signals
- Image not resolved

### **Coating of Specimen**



#### Sputtered Gold

Chromium

# Effects of beam strike angle and distance





The angle of which the beam strikes the specimen (or local curvature) is important for how much signals escape

Distance from the surface are also important

#### Summary

Secondary electrons: topography

 Low energy, high resolution

 Backscattered electrons: chemistry

 High energy, signal dependent on atomic numbers

 X-Ray: chemistry

 Longer recording time, give element fingerprint X-ray signal